

Judul:

Microlithography : process technology for IC fabrication

Pengarang/Penulis:

Elliott, David J., author

Subjek:

Integrated circuits -- Very Large Scale Integration -- Design and construction; Microlithography; Photoresists

Nomor Panggil:

621.381 73 ELL m

Penerbitan:

McGraw-Hill

Link Terkait:

- [Deskripsi Bibliografi](#)
- [Dokumen Yang Mirip](#)
- [Universitas Indonesia Library](#)